THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicantilo ? Ryoisti Mukai

Serial 10/25/8,662

Conf. No.:

Filed:

January 28, 2002

For:

POLYCRYSTALLINE STRUCTURE FILM

AND METHOD OF MAKING SAME

Art Unit:

1771

Examiner:

Piziali, Andrew T.

I hereby certify that this paper is being deposited with the United States Postal Service as FIRST-CLASS mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this date.

August 16, 2007

Date

Registration No. 41,895 Attorney for Applicant(s)

INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Applicants submit a Corrected Form PTO-1449 to replace the Form PTO-1449 filed on August 6, 2007. Applicants inadvertently listed the publication date of KR 1985-0005006 as July 26, 1989. The correct date should be --August 19, 1985--.

It is respectfully requested that the above-listed document be made of record in the present application.

Respectfully submitted,

GREER, BURNS & CRAIN, LTD.

By

Registration No. 41,895

August 16, 2007

300 South Wacker Drive Suite 2500 Chicago, Illinois 60606-6501 Telephone: (312) 360-0080 Facsimile: (312) 360-9315

CORRECTED FORM PTO-1449

Sheet 1 of 1

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Form PTO-1449 U.S. Department of Commerce (Rev. 8-88)				Attorney Docket No.: 2500.66134			Serial No.: 10/058,662		
INFORMATION DISCLOSURE CITATION				Applicant: Ryoichi Mukai					
(Use several sheets if necessary)				Filing Date: January 28, 2002		Group: 1771			
U.S. PATEN	IT DOCUMENTS								
Examiner Initial*	Document Number		Alama.					Date	
		Date Jun. 18, 2002	Chen et	Name	Class	Subclass	If Appi	opriate	
		Aug. 19, 1997	Chen et al.						
		Aug. 19, 1997 Apr. 7, 1998	Ranjan et al.						
			Chen et al.						
		Dec. 22, 1998							
		Nov. 2, 1999	Ranjan et al.						
		Jan. 11, 2000	Chen et al. Kobayashi et al.						
	4,606,802	Aug. 19, 1986	Kobayas	hi et al.					
	- "- <u> "</u>								
FOREIGN P	ATENT DOCUMENTS								
							Transla	ition	
	Document Number	Date	Country		Class	Subclass	Yes	No	
	8-50715	Feb. 20, 1996	Japan				X*		
	1985-0005006	Jul. 26, 1989	Korea				X**		
	1985-0005006	Aug. 19, 1985	Korea				X**		
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)									
									
Examiner			Date Considered						
*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.									

^{*} Corresponds to U.S. Patent Nos. RE37,748; 5,658,659; 5,736,013; 5,851,688; 5,976,326; 6,013,161. ** Corresponds to U.S. Patent No. 4,606,802.